

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Andy Wei et al.

Serial No.: 10/085,903⁴

Filed: February 28, 2002

For: SOI MOSFET JUNCTION
DEGRADATION USING MULTIPLE
BURIED AMORPHOUS LAYERS

§ Group No.: 2823
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§ Examiner: Hsieng Ming Lee
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§ Atty. Dkt. No.: AMDI:115\HON
§
§

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Dear Sir:

CERTIFICATE OF MAILING 37 C.F.R. 1.8

I hereby certify that this correspondence is being deposited with the U.S. Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450, on the date below:

July 24, 2003
Date Timothy M. Honeycutt

**INFORMATION DISCLOSURE STATEMENT
PURSUANT TO 37 C.F.R. 1.97(c) AND 1.98 WITH
STATEMENT PURSUANT TO 37 C.F.R. 1.97(e)(1)**

In compliance with the duty of disclosure under 37 C.F.R. 1.56(a), Applicants respectfully request that this Information Disclosure Statement be entered and that the listed reference(s) be considered by the Examiner and made of record. The listed references were cited in an International Search Report issued for a foreign counterpart application. Copies of the listed references and the International Search Report are enclosed for the convenience of the Examiner.

In accordance with 37 C.F.R. 1.97, this Information Disclosure Statement is not to be construed as a representation that a search has been made, as an admission that the information cited herein is, or is considered to be, material to patentability as defined in 37 C.F.R. 1.56(b), or as a representation that no other possibly material information, as defined in 37 C.F.R. 1.56(b), exists.

The following information is listed below in accordance with 37 C.F.R. 1.98. Any explanation of non-English language documents contained in this Information Disclosure Statement is believed to constitute a concise explanation of the relevance of the listed

reference(s) as they are presently understood by the individual designated in 37 C.F.R. 1.56(c) most knowledgeable about the content of the listed reference(s), in accordance with 37 C.F.R. 1.98(a)(3).

U.S. PATENTS

Patentee	Patent Number	Issue Date
Makoto Yoshimi et al.	5,698,869	December 16, 1997
Matthew S. Buynoski	5,825,066	October 20, 1998
Bin Yu	US 6,225,176 B1	May 1, 2001

FOREIGN PATENTS

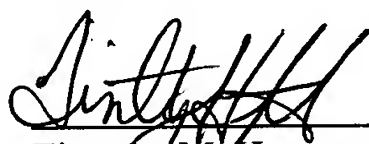
Country or Issuing Patent Office	Document Number	Publication Date
EPO	EP 0 935 389 A	August 11, 1999
PCT	WO 03 012844 A	February 13, 2003
Japan	JP2001244477 A	September 7, 2001

The Commissioner is authorized to charge any required fees or credit any overpayment to Deposit Account No. 01-0365, Order No. AMDI:115\HON.

Respectfully submitted,

Date:

July 24, 2003



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Form PTO-1449 (modified) List of Patents and Publications For Applicant's Information Disclosure Statement (Use several sheets if necessary)		ATTY. DOCKET NO. AMDI:115\HON		SERIAL NO. 10/085,903	
		APPLICANT Andy Wei et al.		CERTIFICATE OF MAILING 37 C.F.R. 1.8 I hereby certify that this correspondence is being deposited with the U.S. Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450, on the date below: <div style="display: flex; justify-content: space-between;"> <div style="text-align: center;"> <u>July 24, 2003</u> <small>Date</small> </div> <div style="text-align: center;"> <small>Timothy M. Honeycutt</small> </div> </div>	
				FILING DATE July 23, 2003	

U.S. PATENT DOCUMENTS							
EXAM INIT.	REF. DES.	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
	A1	5,698,869	December 16, 1997	Makoto Yoshimi et al.	257	192	
	A2	5,825,066	October 20, 1998	Matthew S. Buynoski	257	345	
	A3	US 6,225,176 B1	May 1, 2001	Bin Yu	438	305	

FOREIGN PATENT DOCUMENTS							
EXAM INIT.	REF. DES.	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	TRANSLATION
	A4	EP 0 935 389 A	August 11, 1999	EPO	H04N	5/74	
	A5	WO 03 012844 A	February 13, 2003	PCT	H01L	21/265	
	A6	JP2001244477 A	September 7, 2001	Japan	H01L	29/786	

OTHER ART		
EXAM INIT.	REF. DES.	AUTHOR; TITLE; JOURNAL; VOLUME; DATE; PERTINENT PAGES

EXAMINER	DATE CONSIDERED
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Information Disclosure Statement--PTO-1449 (Modified)